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## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 2000-127953 04/27/2000  
  
 JAPAN 2000-311124 10/11/2000

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY	SHEETS	TOTAL	INDEPENDENT
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## TITLE

Film formation method, semiconductor element and method thereof, and method of manufacturing a disk-shaped storage medium

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